

Abstract

A laser apparatus and a method of directing laser to a workpiece surface

Disclosed is a laser apparatus comprising: i) an imaging device having an optical path for capturing an image of a workpiece surface; ii) an laser-emitting device configured to direct laser along a laser path to the workpiece surface, the laser path of the laser-emitting device being separate from the optical path of the imaging device; and iii) a controller coupled to the imaging device and the laser-emitting device, the controller being configured to adjust the laser path of the laser-emitting device based on an image of the workpiece surface as captured by the imaging device. A method of directing laser to a workpiece surface is also disclosed.

[FIG. 2b]